

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

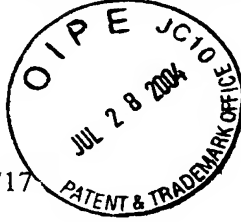
In re the Application of

Takeshi KIJIMA et al.

Application No.: 10/800,717

Filed: March 16, 2004

For: METHOD OF MANUFACTURING CERAMIC FILM AND PRESSURE HEAT  
TREATMENT DEVICE USED THEREFOR



Group Art Unit: 1755

Docket No.: 119113

**CLAIM FOR PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested for the above-identified patent application and the priority provided in 35 U.S.C. §119 is hereby claimed:

Japanese Patent Application No. 2003-073929 filed March 18, 2003

In support of this claim, a certified copy of said original foreign application:

☒ is filed herewith.

It is requested that the file of this application be marked to indicate that the requirements of 35 U.S.C. §119 have been fulfilled and that the Patent and Trademark Office kindly acknowledge receipt of this document.

Respectfully submitted,

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Date: July 28, 2004

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